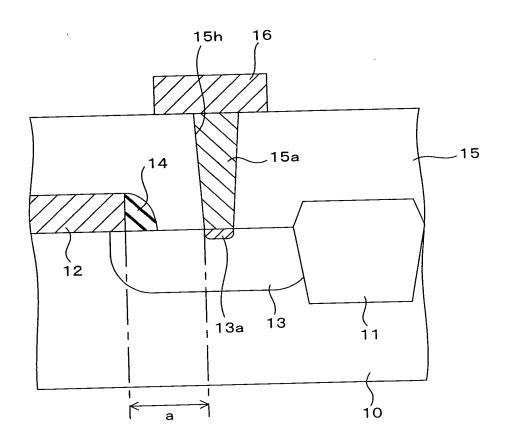
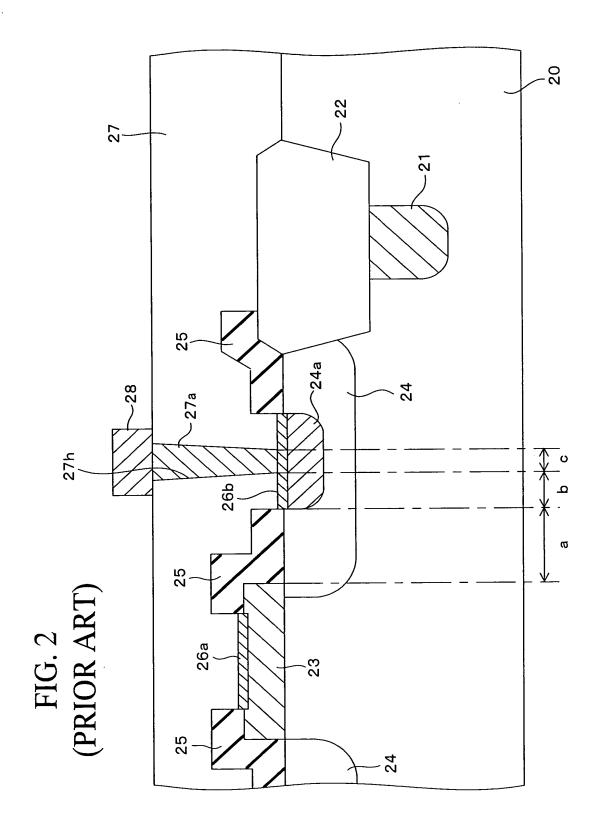
FIG. 1 (PRIOR ART)





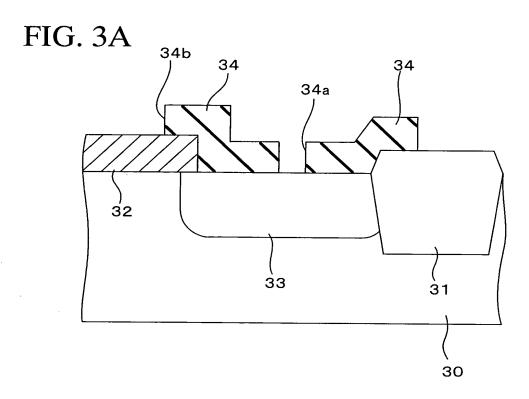
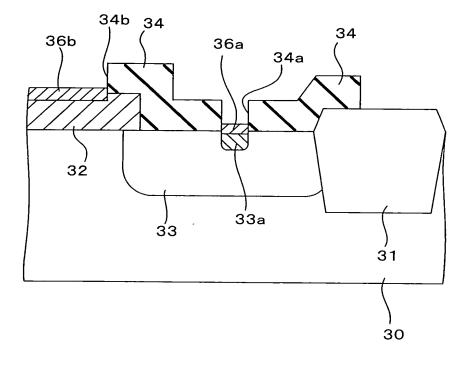
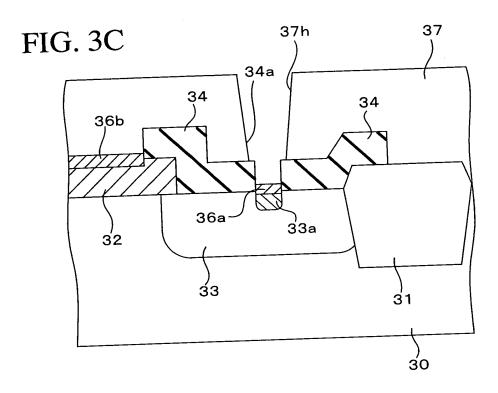


FIG. 3B



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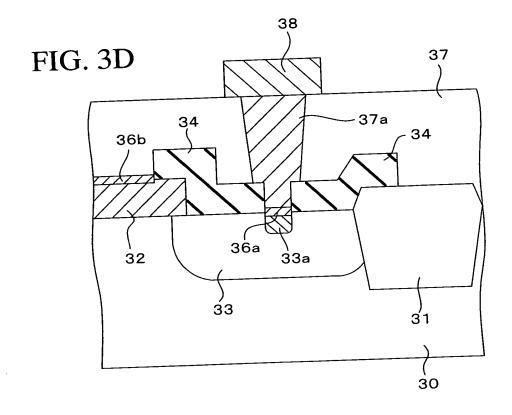


FIG. 4

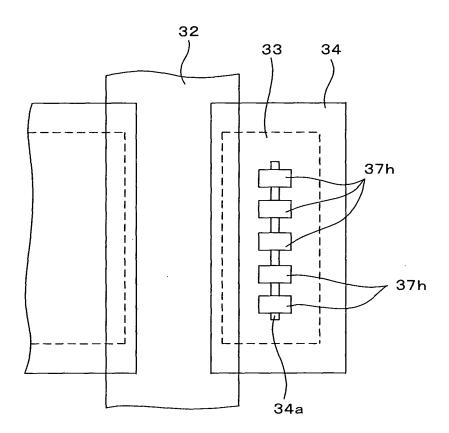
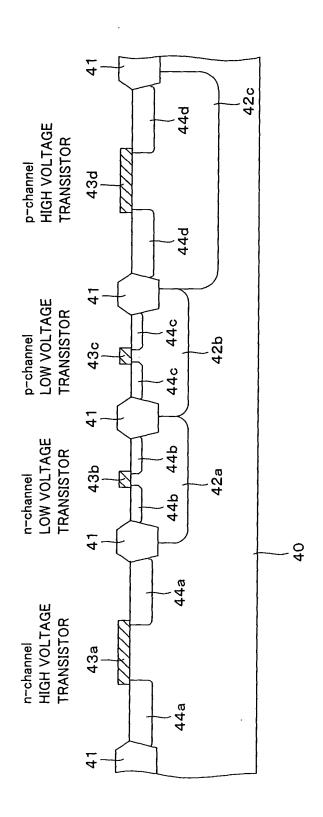
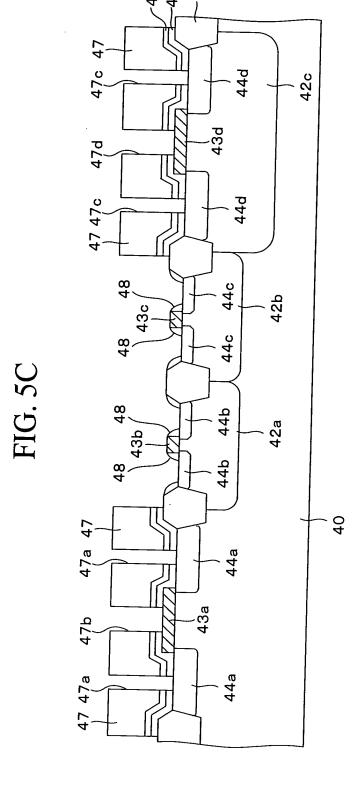


FIG. 5A



44d 43d 42b 43c 44b 43b 44b 40



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42c 44q 42b 44c 43c 50b 42a 48 20p 40

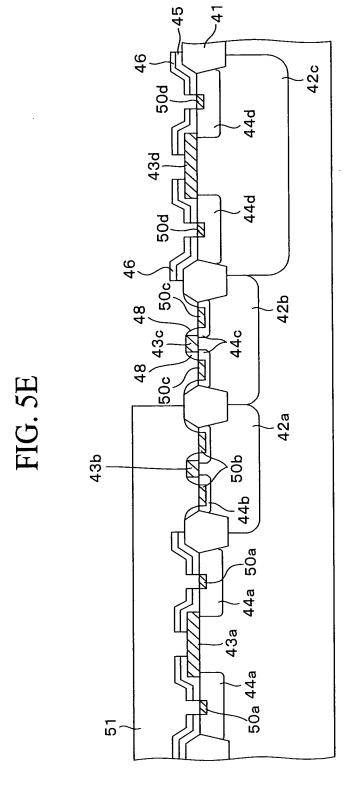
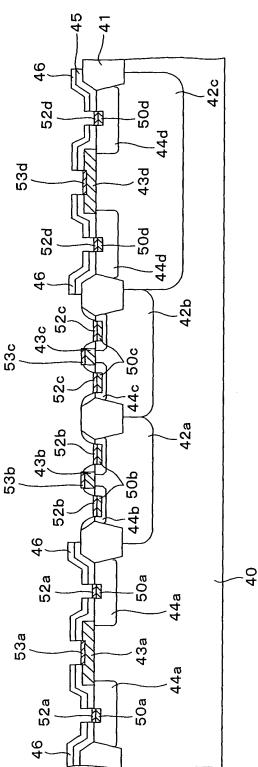


FIG. 5F



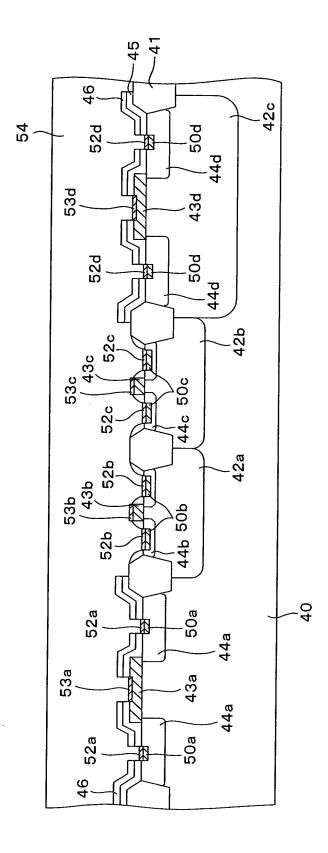
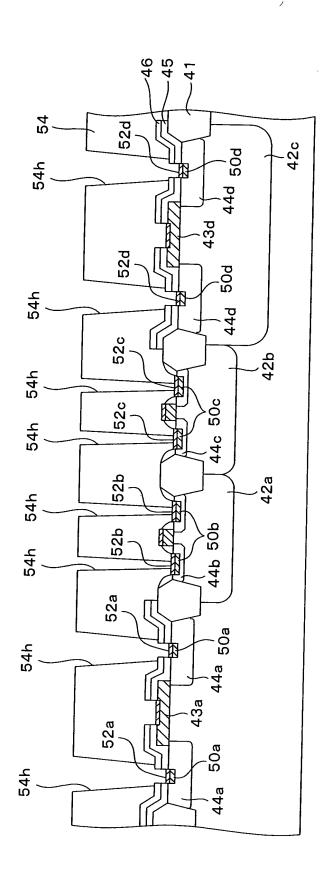


FIG. 5H





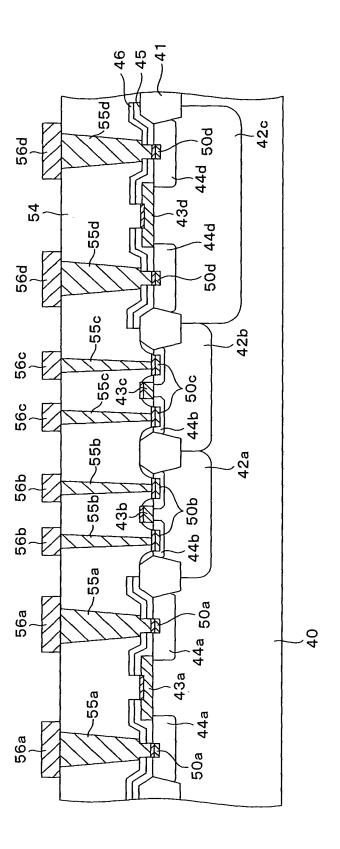


FIG. 6A

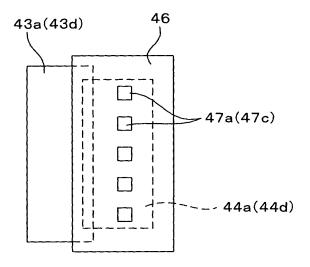


FIG. 6B

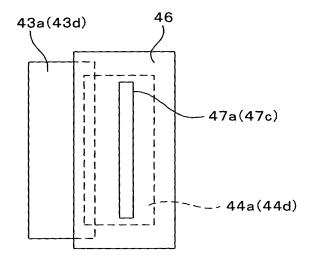


FIG. 7A

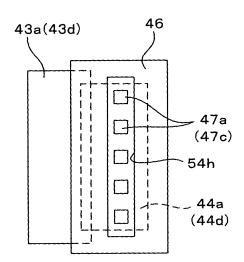


FIG. 7B

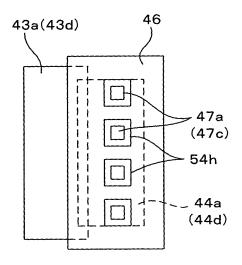


FIG. 7C

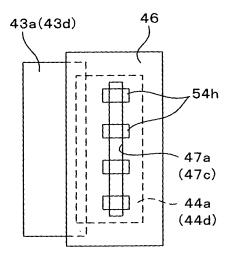


FIG. 7D

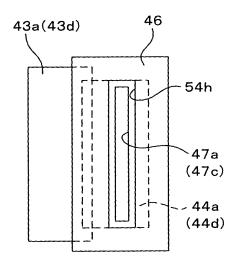


FIG. 8A

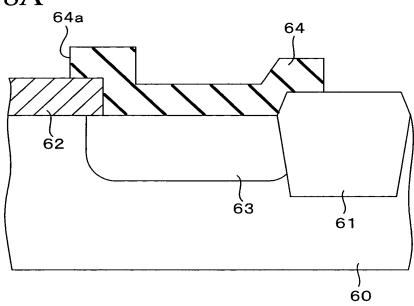


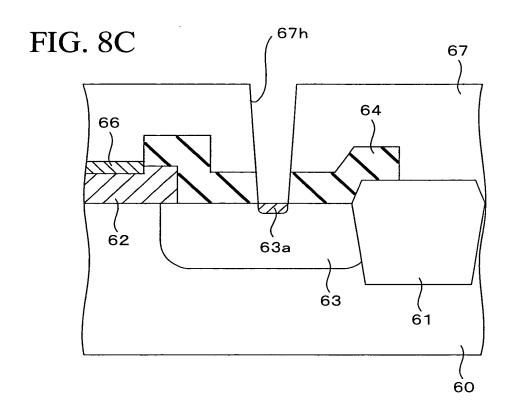
FIG. 8B

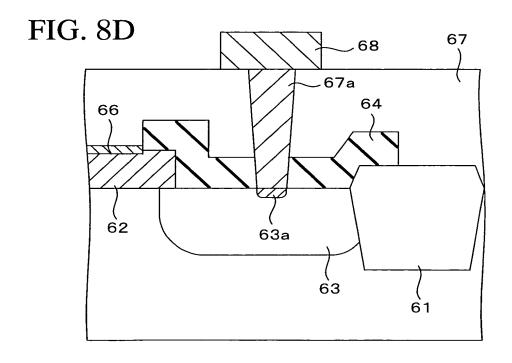
67

64

63

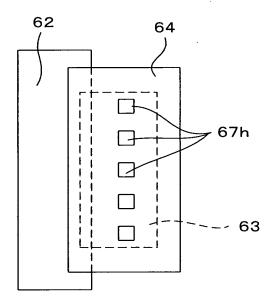
61





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FIG. 9



## FIG. 10A

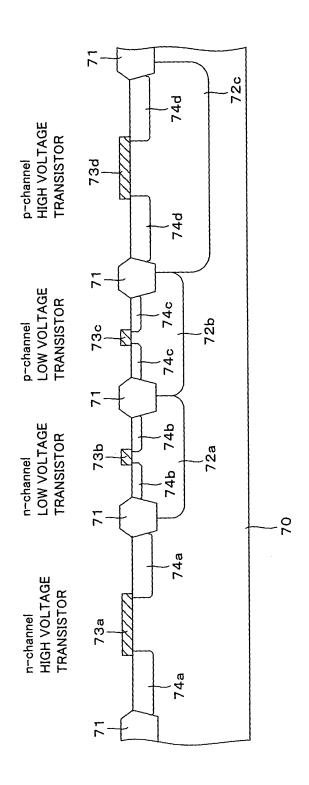


FIG. 10B

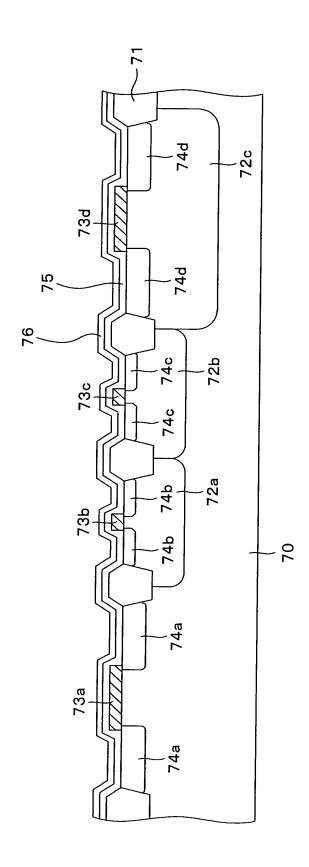
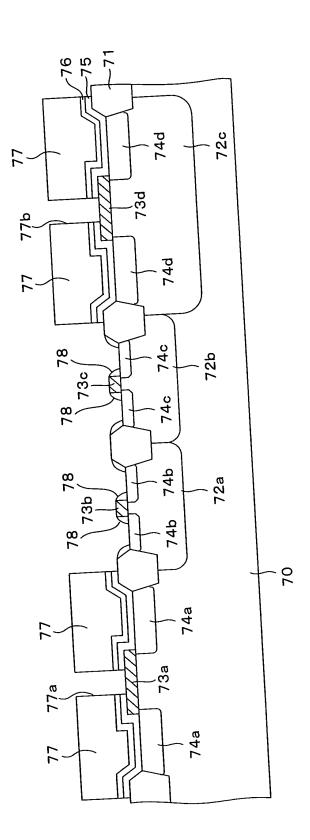


FIG. 10C



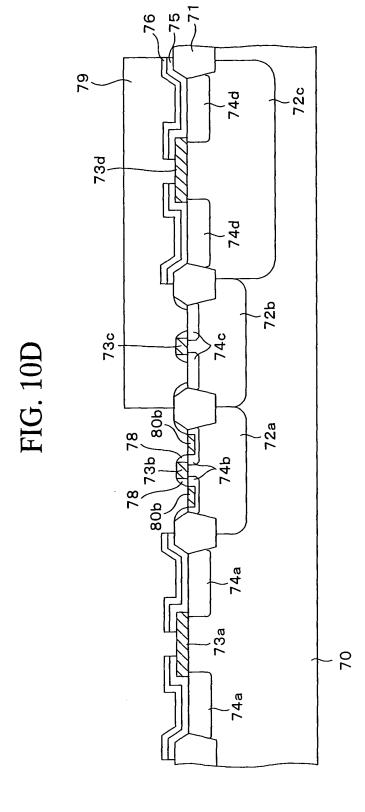


FIG. 10E

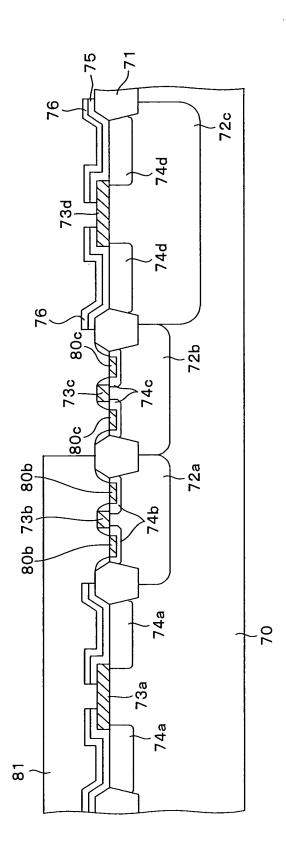
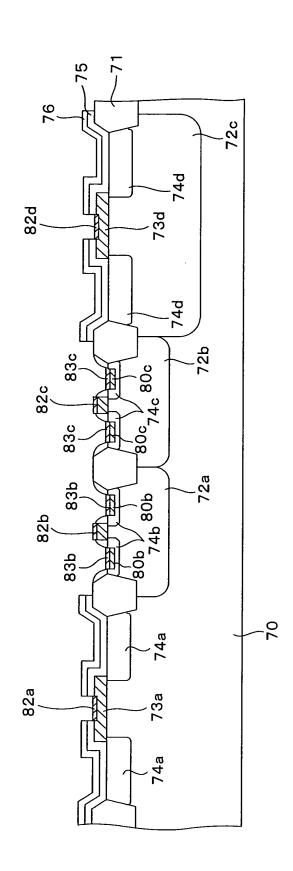
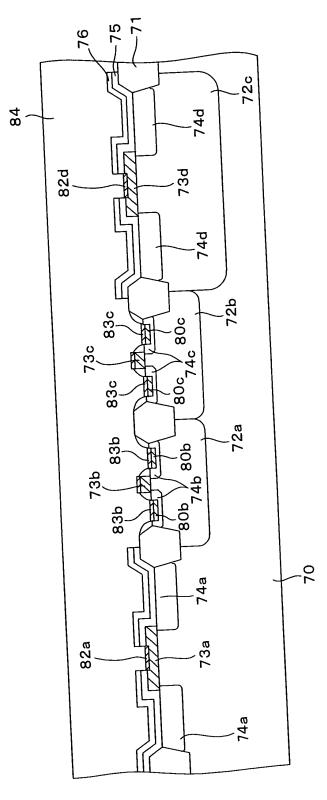
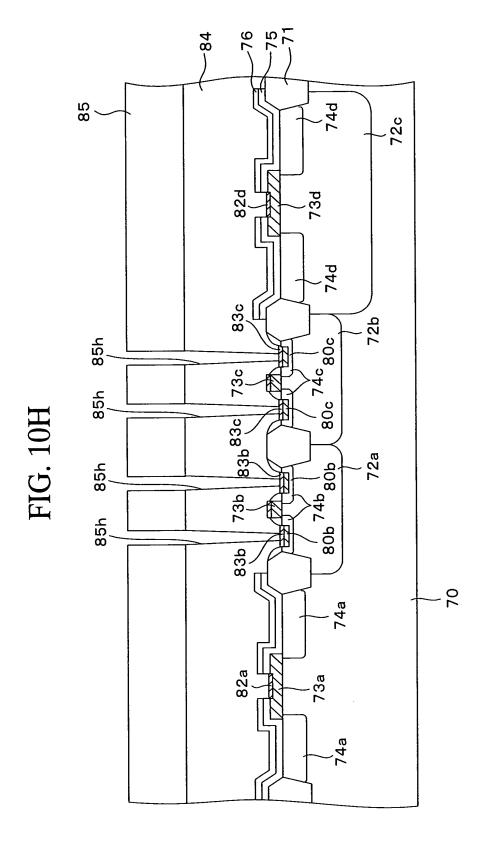


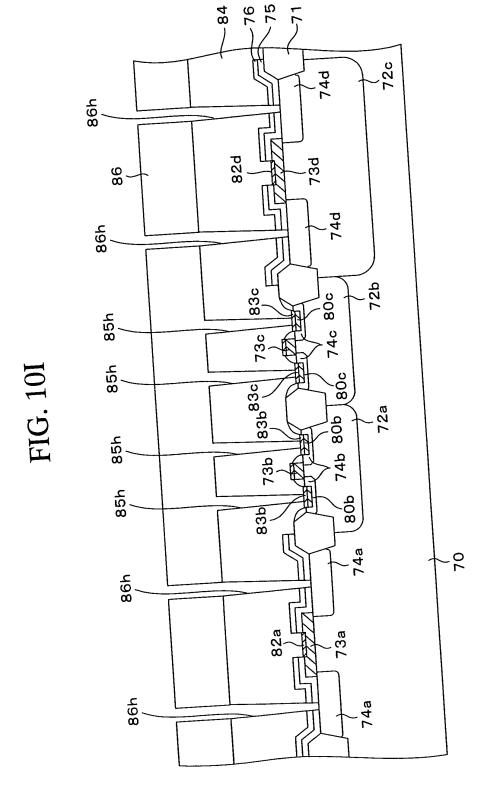
FIG. 10F

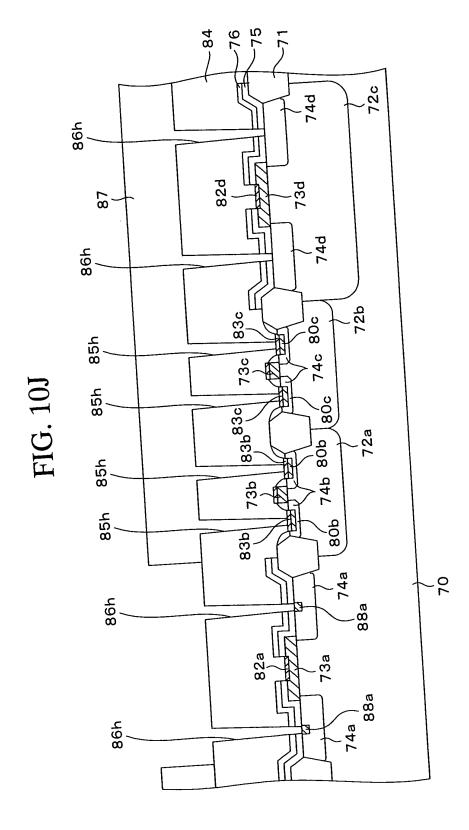


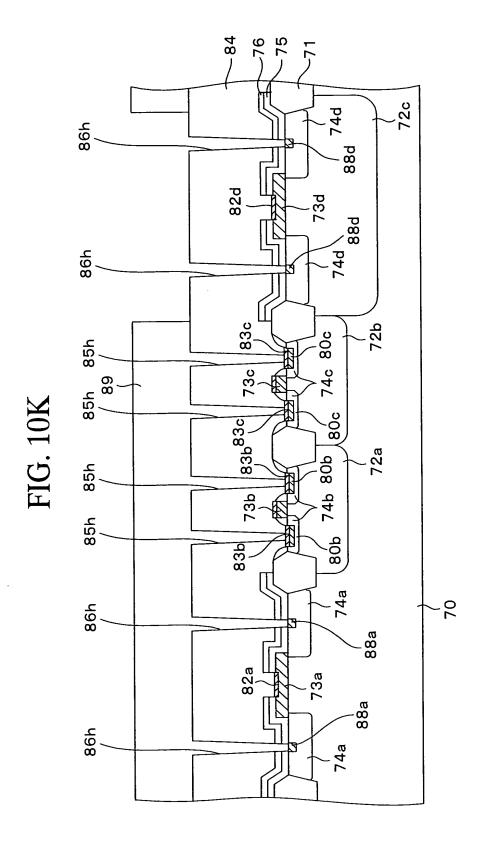












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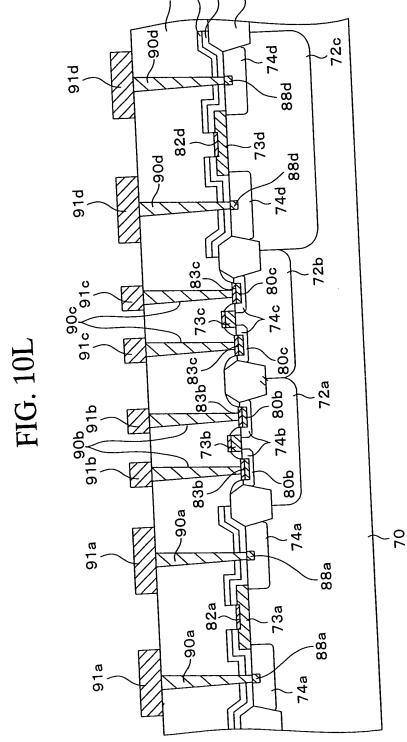


FIG. 11A

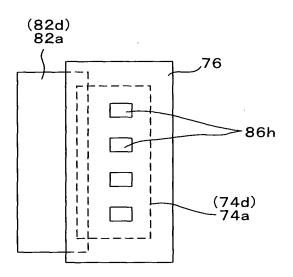


FIG. 11B

